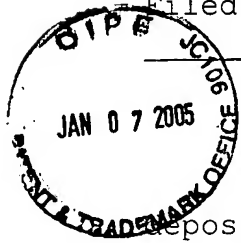



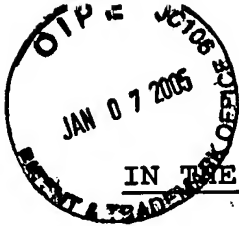
In re Patent Application of:
MORIN ET AL.
Serial No. **10/701,165**
Confirmation No. **5541**
Filed: **11/4/03**



CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
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3rd day of January, 2005.

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IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
MORIN ET AL.)
Serial No. 10/701,165) Examiner: S. Gebremariam)
Confirmation No. 5541) Art Unit: 2811)
Filing Date: November 4, 2003) Attorney Docket:)
02GR1098/54488)
For: SEMICONDUCTOR DEVICE WITH MOS)
TRANSISTORS WITH AN ETCH-STOP LAYER)
HAVING AN IMPROVED RESIDUAL STRESS)
LEVEL AND METHOD FOR FABRICATING)
SUCH A SEMICONDUCTOR DEVICE)

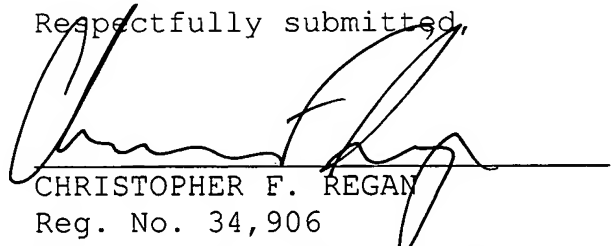
RESPONSE TO REQUIREMENT FOR RESTRICTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The restriction requirement mailed on December 2, 2004 incorrectly considered canceled Claims 1-11. Applicants respectfully request that a new office action be issued directed to Claims 12-38 added by Preliminary Amendment of November 4, 2003 (see attached facsimile transmission of December 6, 2004).

Respectfully submitted,


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